Electronic Patent Application Fee Transmittal							
Application Number:	105	10510695					
Filing Date:	08-Oct-2004						
Title of Invention:	METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL, SILICON SINGLE CRYSTAL AND SILICON WAFER						
First Named Inventor/Applicant Name:	Izumi Fusegawa						
Filer:	Christopher W. Brown/Jori Krischke						
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